

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of

Mitsubishi MAKI

Serial No.: 09/909,975

Group Art Unit: 2811

Filed: July 23, 2001

Examiner: Thien Tran

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD OF THE SAME

RESPONSE TO RESTRICTION REQUIREMENTCommissioner for Patents  
Washington, DC 20231

Sir:

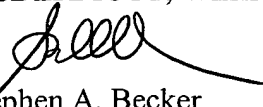
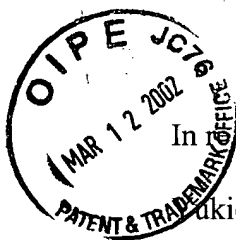
Noting the Office Action of February 13, 2002 wherein restriction has been required, Applicant(s) hereby elect Group I (claims 1-6) for prosecution in the above-identified Rejoinder of the non-elected process claims upon allowance of counterpart elected claims is requested.

application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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